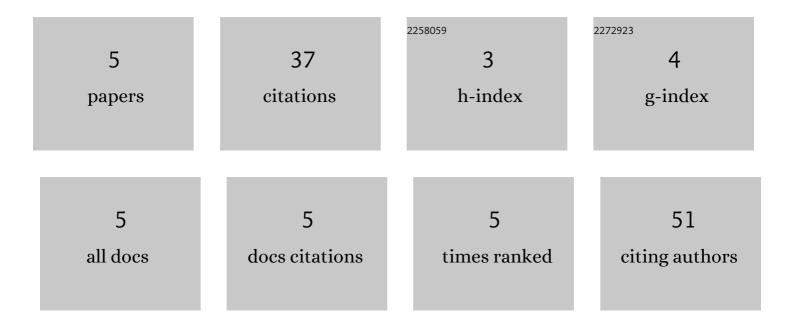
## **Guk-Jong Choi**

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/2411466/publications.pdf Version: 2024-02-01



#	Article	IF	CITATIONS
1	Dual-wavelength Fourier ptychography using a single LED. Optics Letters, 2018, 43, 3526.	3.3	12
2	Low-cost strategy for time delay adjustment of STED microscopy using digital oscilloscope. , 2015, , .		0
3	Experimental demonstration of line-width modulation in plasmonic lithography using a solid immersion lens-based active nano-gap control. Applied Physics Letters, 2015, 106, .	3.3	7
4	Improved Nanogap Servo System Using an Error-Based Disturbance Observer for High-Speed in Solid Immersion Lens-Based Plasmonic Lithography. Japanese Journal of Applied Physics, 2013, 52, 09LG02.	1.5	2
5	High-speed plasmonic nanolithography with a solid immersion lens-based plasmonic optical head. Applied Physics Letters, 2012, 101, .	3.3	16